

MATTINGLY, STANGER & MALUR, P.C.

JOHN R. MATTINGLY*
DANIEL J. STANGER
SHRINATH MALUR*

GENE W. STOCKMAN
Of Counsel

JEFFREY M. KETCHUM
SCOTT W. BRICKNER
Registered Patent Agents

* Bar Membership Other Than Virginia

ATTORNEYS AT LAW
104 EAST HUME AVENUE
ALEXANDRIA, VIRGINIA 22301

PATENT, TRADEMARK
AND COPYRIGHT LAW
FACSIMILE (703) 684-1157

(703) 684-1120

Date: March 14, 2001

Attorney Docket No. NIP-230

To: Assistant Commissioner for Patents
Washington, D.C. 20231

Sir: Transmitted herewith for filing is the patent application of:

Inventor: S. ICHIMURA et al (SEE ATTACHED)

For:
NEUTRAL BEAM PROCESSING APPARATUS AND METHOD

Enclosed are:

- ☒ 5 Sheets of Drawings
- ☒ This application is being filed without an executed Declaration.
- Priority is claimed from Japanese Application No. 2000-113519
filed April 14, 2000. ☒ A certified copy is attached herewith.
- Copies of the disclosure documents listed on the attached PTO 1449 form and
☒ discussed in the specification or ☒ attached Information Disclosure Statement.
- ☐ A verified statement to establish small entity status under 37 CFR 1.9 and 1.27.
- ☒ Specification: Abstract X, Description 48 pages; and 10 claim(s).
- ☒ Preliminary Amendment.
- ☐ Executed Declaration.

The filing fee is calculated as shown below:

For:	No. Filed	No. Extra
Basic Fee		
Total Claims	10 - 20 = *	0
Indep Claims	6 - 3 = *	3
<input type="checkbox"/> Multiple Dependent Claim (s)		

* If difference is less than zero
then enter '0' in second column

Small Entity	
Rate	Fee
	\$ 355
x 9	\$
x 40	\$
+ 135	\$
Total	\$

Large Entity	
Rate	Fee
	\$ 710
x 18	\$ 0
x 80	\$ 240
+ 270	\$ 0
Total	\$ 950

☒ A check in the amount of \$ 950.00 is enclosed for the filing fee.

☒ The Commissioner is hereby authorized to charge any additional fees that may be required to
Deposit Account No. 50-1417.

Respectfully Submitted,

By: John R. Mattingly
John R. Mattingly
Registration No. 30,293

03/14/01
1c772 U.S. PTO

11036 U.S. PTO
09/805237
03/14/01

LIST OF INVENTORS' NAMES AND ADDRESSES

Satoshi ICHIMURA, Hitachi, JAPAN;

Katsutoshi TSUCHIYA, Hitachi, JAPAN;

Tadashi SATO, Mito, JAPAN;

Yoshihiko NAGAMINE, Hitachi, JAPAN;

Yoshiya HIGUCHI, Tokai, JAPAN.